

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	10/620,743	CHOU ET AL.
	Examiner	Art Unit
	Jennifer M. Kennedy	2812

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
438	243-249	4/28/2005	JMK
438	386-392	4/28/2005	JMK
257	301-305	4/28/2005	JMK